This Page Is Inserted by IFW Operations and is not a part of the Official Record

BEST AVAILABLE IMAGES

Defective images within this document are accurate representations of the original documents submitted by the applicant.

Defects in the images may include (but are not limited to):

- BLACK BORDERS
- TEXT CUT OFF AT TOP, BOTTOM OR SIDES
- FADED TEXT
- ILLEGIBLE TEXT
- SKEWED/SLANTED IMAGES
- COLORED PHOTOS
- BLACK OR VERY BLACK AND WHITE DARK PHOTOS
- GRAY SCALE DOCUMENTS

IMAGES ARE BEST AVAILABLE COPY.

As rescanning documents will not correct images, please do not report the images to the Image Problem Mailbox.



| JH Ref _ P68950U50 ; | Today's Date SEPTEMBER 25, 2003 |
|---|--|
| | 609,052 |
| | IG-KWON LEE, ETAL. |
| Filing Date/Patent Date | NE 21, 2003 |
| The following has been received in the U.S. | 3. Patent & Trademark Office on the date stamped hereon: |
| pp. Specification & | Claims |
| ☐ Combined Declaration, Power of Attorn | e Disclosure Statement-IDS |
| ☐ Preliminary Amendment | O Copies of References |
| ☐ Rule 53 (b) Application | Request for Refund |
| ☐ Rule 53 (d) /RCE Application | SEP 2 5 2003 Poly Request for Corrected Filing Receipt |
| Claim to Priority and Certified Copy | Petition for XOT |
| ☐ Substitute ☐ Subsequent Decision | Notice of Appeal/Brief |
| ☐ Maintenance Fee | Notice of Appeal/Brief Sequence Listing |
| ☐ Drawings SheetsFormat | |
| ☐ Assignment/Change of Name | ☐ Other :: |
| ☐ Small Entity Declaration | for the state of t |
| Check for \$ | JACOBSON HOLMAN PLLC |
| CHECK IOI & | 400 SEVENTH STREET, N.W. |
| JH 11/01 DUE DATE | WÄSHINGTON, D.C. 20004 |
| Person filing YSH Ai | |
| reison illing | |





PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Sung-Kwon LEE, et al.

Serial No.: 10/607,052

Group Art Unit: 2812

Filed: June 27, 2003

Examiner: Not Yet Assigned

Title: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE CAPABLE OF

REDUCING SEAM GENERATIONS

CLAIM FOR PRIORITY UNDER 35 U.S.C. §119

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 25, 2003

Sir:

The benefit of the filing date of prior foreign application No. 2002-84097, filed in Korea on December 26, 2002, is hereby requested and the right of priority provided in 35 U.S.C. §119 is hereby claimed.

In support of this claim, filed herewith is a certified copy of said original foreign application.

Respectfully submitted,

Req. No. 45,307

JACOBSON HOLMAN, PLLC The Jenifer Building 400 Seventh Street, N.W. Washington, D.C. 20004-2201 Telephone: (202) 638-6666

Atty. Docket No.: P68950US0

YSH:di





해한 민국특 하 KOREANINTELLECTUAL PROPERTY OFFICE

별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the following application annexed hereto is a true copy from the records of the Korean Intellectual Property Office.

출 원 번 호

10-2002-0084097

Application Number

출 원 년 월 일 Date of Application 2002년 12월 26일

DEC 26, 2002

출 원 Applicant(s) 인

주식회사 하이닉스반도체

Hynix Semiconductor Inc.

², 2003

녀 06

27

일



7

청

COMMISSIONE





| VJH Ref 18950USO | | Today's pate SETEMBER 25, 2003 |
|-------------------------------------|----------------------|---|
| Serial/Patent No. | : 0 601,052 | · / |
| Applicant, Patentee, Assignee | SUNG-KWON | ILE, ETAL. |
| Filing Date/Patent Date | JUNE 27, 2 | 2003 |
| The following has been received in | the U.S. Patent & Tr | rademark Office on the date stamped hereon: |
| pp. Specification | &Cla | aims Response to Office Action |
| □ Combined Declaration, Power of | of Attoprey P | ☐ Disclosure Statement-IDS |
| □ Preliminary Amendment | / 0 ~ | ☐ Copies of References |
| ☐ Rule 53 (b) Application | 0 T 2002 | ☐ Request for Refund. |
| ☐ Rule 53 (d) /RCE Application | SEP 2 5 2003 | ☐ Request for Corrected Filing Receipt |
| ☑ Claim to Priority and Certified C | OP/2 | ☐ Petition for XOT |
| ☐ Substitute ☐ Subsequer | nt Declaration | ☐ Notice of Appeal/Brief |
| ☐ Maintenance Fee | TRADEMAN | ☐ Sequence Listing |
| ☐ Drawings Sheets | FormalInforma | al 🔲 Issue Fee Transmittal |
| ☐ Assignment/Change of Name | | ☐ Other |
| ☐ Small Entity Declaration | • | |
| ☐ Check for \$ | | JACOBSON HOLMAN PLLC |
| | | 400 SEVENTH STREET, N.W. |
| JH 11/01 DUE DATE | | WASHINGTON, D.C. 20004 |
| Person filingYSHId | j | |
| | | |



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Sung-Kwon LEE, et al.

Serial No.: 10/607,052

Group Art Unit: 2812

Filed: June 27, 2003

Examiner: Not Yet Assigned

Title: METHOD FOR FABRICATING SEMICONDUCTOR DEVICE CAPABLE OF

REDUCING SEAM GENERATIONS

CLAIM FOR PRIORITY UNDER 35 U.S.C. §119

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 25, 2003

Sir:

The benefit of the filing date of prior foreign application No. 2002-37257, filed in Korea on June 29, 2002, is hereby requested and the right of priority provided in 35 U.S.C. §119 is hereby claimed.

In support of this claim, filed herewith is a certified copy of said original foreign application.

Respectfully submitted,

By: Non S Ham by Sugar C Falon Youn S. Ham Reg. No. 45,307 Reg N. 40,495

JACOBSON HOLMAN, PLLC The Jenifer Building 400 Seventh Street, N.W. Washington, D.C. 20004-2201 Telephone: (202) 638-6666

Atty. Docket No.: P68950US0 YSH:dj



대한민국,특허청 KOREANINTELLECTUAL PROPERTY OFFICE

별첨 사본은 아래 출원의 원본과 동일함을 증명함.

This is to certify that the followin \cdot plication annexed hereto is a true copy from the records c^* the Korean Intellectual Property Office.

출 원 번 호 : 10-2002-0037257

Application Number

출 원 년 월 일 : 2002년 06월 29일 Date of Application JUN 29, 2002

출 원 인 : 주식회사 하이닉스반도체 Applicant(s) Hynix Semiconductor Inc.

2003 년 05 월

허 청 COMMISSIONER